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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasutaka ITO

Group Art Unit: 3742

Application No.: 09/917,749

Examiner: J. Jeffery

Filed: July 31, 2001

Docket No.: 110575.01

For: CERAMIC HEATER FOR A WAFER WITH OFFSET ELECTRIC HEATING
ELEMENTS IN THE THICKNESS DIRECTION (As Twice Amended)

SUPPLEMENTAL AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

RECEIVED
AUG 14 2002
TECHNOLOGY CENTER R3700

Sir:

As a supplement to the amendment filed on August 12, 2002, please further amend
the above-identified application as follows:

IN THE TITLE:

Please replace the title so that it reads as follows:

CERAMIC HEATER FOR A WAFER WITH OFFSET ELECTRIC HEATING ELEMENTS
IN THE THICKNESS DIRECTION

IN THE SPECIFICATION:

Page 5, line 4 - line 11

In order to solve the above-identified problem, a ceramic heater according to the
present invention comprises heat generation means disposed embedded in a ceramic
substrate, at least some of the heat generation means being formed so as to be located in
positions in the direction of thickness of the ceramic substrate different from the location of
others of the heat generation means.